



Commissioner for Patents
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Bib Data Sheet

CONFIRMATION NO. 7506

SERIAL NUMBER 10/060,204	FILING DATE 09/24/2002 RULE	CLASS 034	GROUP ART UNIT 3749	ATTORNEY DOCKET NO. 520.30414R49
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APPLICANTS

Shigekazu Kato, Kudamatsu-shi, JAPAN;
kouji Nishihata, Tokuyama-shi, JAPAN;
Tsunehiko Tsubone, Hikari-shi, JAPAN;
Atsushi Itou, Kudamatsu, JAPAN;

**** CONTINUING DATA *******

This application is a REI of 09/767,834 01/24/2001 PAT 6,332,280
which is a CON of 09/766,587 01/23/2001
which is a DIV of 09/461,432 12/16/1999 PAT 6,330,755
which is a CON of 09/177,495 10/23/1998 PAT 6,012,235
which is a CON of 09/061,062 04/16/1998 PAT 5,950,330
which is a CON of 08/882,731 06/26/1997 PAT 5,784,799
which is a DIV of 08/593,870 01/30/1996 PAT 5,661,913
which is a CON of 08/443,039 05/17/1995 PAT 5,553,396
which is a DIV of 08/302,443 09/09/1994 PAT 5,457,896
which is a CON of 08/096,256 07/26/1993 PAT 5,349,762
which is a CON of 07/751,952 08/29/1991 ABN

**** FOREIGN APPLICATIONS *******

JAPAN 02-225321 08/29/1990

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 04/05/2002

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 1	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 12
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials		

ADDRESS

020457

TITLE *PAN 8/31/03*

Vacuum processing apparatus

with wafers, substrates and/or semiconductors

FILING FEE RECEIVED 870	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees (Filing)
		<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
		<input type="checkbox"/> 1.18 Fees (Issue)